



FITCH EVEN TABIN & FLANNERY
INTELLECTUAL PROPERTY LAW | EST. IN 1859

IFW

Michael A. Sanzo
Telephone: (202) 419-7013
Email: msanzo@fitcheven.com

November 13, 2006

Commissioner of Patents
U.S. Patent and Trademark Office
Customer Service Window
MAIL STOP Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Re: Filing of Information Disclosure Statement
Appl. No.: 10/549,680
Filed: September 19, 2005
Title: **High Homogeneity Silica Glass Prepared Through A Sol-Gel Procedure**
Inventor(s): Fulvio COSTA, *et al.*
Atty. Dkt.: 7601/84392

Sir:

The following documents are being forwarded for appropriate action by the U.S. Patent and Trademark Office:

1. Information Disclosure Statement;
2. PTO/SB/08a;
3. References: B1 and C1-C2.

The Commissioner is hereby authorized to charge any fee deficiency with respect to this filing and any other fee required in connection with the present case, or credit any overpayment, to our Deposit Account No. 06-1135 under Order No. 7601/84392.

Commissioner of Patents
November 13, 2006
Page 2

It is respectfully requested that the enclosed postcard be stamped with the date the enclosed documents are received by the PTO and that it be returned as soon as possible.

Respectfully submitted,

FITCH, EVEN, TABIN & FLANNERY

A handwritten signature in cursive script, reading "Michael A. Sanzo", is written over a horizontal line.

Michael A. Sanzo
Attorney for Applicant
Registration No. 36,912

MAS/crh
Enclosures



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:

Fulvio COSTA, *et al.*

Appl. No.: 10/549,680

Filed: September 19, 2005

For: **High Homogeneity Silica Glass Prepared
Through a Sol-Gel Procedure**

Art Unit: 1731

Examiner: Not Yet Assigned

Atty. Dkt.: 7601/84392

Information Disclosure Statement

MAIL STOP - AMENDMENT

Commissioner of Patents
U.S. Patent and Trademark Office
P.O. Box 1450
Arlington, Virginia 22131-1450

Sir:

Submitted herewith is a listing of documents known to Applicants and/or their attorney in compliance with the requirements of 37 C.F.R. § 1.56. Some of these references were cited in an International Search Report dated July 5, 2004 in the corresponding international application, a copy of which is enclosed. Copies of the listed documents, with the exception of United States patent references, are also enclosed.

Applicants do not waive any rights to appropriate action to establish patentability over any of the listed documents should they be applied as references against the claims of the present application. This statement should not be construed as a representation that more material information does not exist or that an exhaustive search of the relevant art has been made.

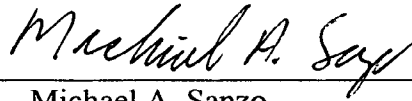
Consideration of the cited documents and making the same of record in the prosecution of the above-captioned application are respectfully requested.

Applicants do not believe any fee is due for the submission of this Information Disclosure Statement. However, the Commissioner is hereby authorized to charge any fee deficiency to our Deposit Account No. 06-1135 under Order No. 7601/84392.

Respectfully submitted,

FITCH, EVEN, TABIN & FLANNERY

By



Michael A. Sanzo

Reg. No. 36,912

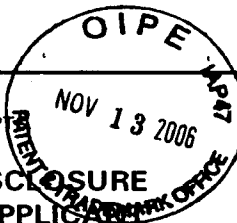
Attorney for Applicants

Date: **November 13, 2006**

1120 20th Street, N.W., Suite 750S

Washington, DC 20036

Phone: (202) 419-7013



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet	1	of	2	Application Number	10/549,680
				Filing Date	September 19, 2005
				First Named Inventor	Fulvio COSTA, <i>et al.</i>
				Art Unit	1731
				Examiner Name	Not Yet Assigned
				Attorney Docket	7601/84392

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ²			
/QSD/	A1	5,068,208	11-26-1991	HAUN, <i>et al.</i>	
/QSD/	A2	5,063,179	11-05-1991	MENASHI, <i>et al.</i>	
/QSD/	A3	4,681,615	07-21-1987	TOKI, <i>et al.</i>	
/QSD/	A4	6,360,564	03-26-2002	CORNELIUS, <i>et al.</i>	
	A5				
	A6				
	A7				
	A8				
	A9				
	A10				

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵				
/QSD/	B1	EP 0 310 486	03-18-1992			

Examiner Signature	/Queenie Dehghan/	Date Considered	10/17/2008
--------------------	-------------------	-----------------	------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kind Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04.

³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

PTO/SB/08b Substitute for Form 1449B/PTO				Application Number	10/549,680
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Filing Date	September 19, 2005
				First Named Inventor	Fulvio COSTA, <i>et al.</i>
				Art Unit	1731
				Examiner Name	Not Yet Assigned
Sheet	2	of	2	Attorney Docket	7601/84392
NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T²
/QSD/	C1	International Search Report Dated July 5, 2004			
/QSD/	C2	T.Y. TSENG, et al., "Various Atmosphere Effects on Sintering Of Compacts of SiO2 Microspheres", Journal of Materials Science 21:3615-3624 (1986)			
Examiner Signature	/Queenie Dehghan/			Date Considered	10/17/2008

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.